JAN 09 2004 09:17 FR LEE - HAYES PLL 1 509 323 8979 TO 17038729306

P.01/17

 HEWLETT-PACKARD COMPANY Intellectual Property Administration P. O. Box 272400 Fort Collins, Colorado 80527-2400

PATENT APPLICATION

ATTORNEY DOCKET NO. __10004054-1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s):

Hodges et al.

Confirmation No.: 8400

Application No.: 10/052,313

Examiner: Lee, H.

Filing Date:

01/18/2002

Group Art Unit: 2823

Title:

Semiconductor Device with Deposited Oxide

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Commissioner for Patents PO Box 1450

Alexandria, VA 22313-1450

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JAN 0 9 2004

TRANSMITTAL LETTER FOR RESPONSE/AMENDMENT

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() Other: _

Transmitted herewith is/are the following in the above-identified application:

(fee \$

		and an are mentioned appropriate.	
(X)	Response/Amendment	() Petition to extend time to	respond
()	New fee as calculated below	() Supplemental Declaration	•
(X)	No additional fee (Address e	velope to "Mail Stop Non-Fee Amendment")	

(1) FOR	(2) CLAIMS REMAINING AFTER AMENDMENT	(3) NUMBER EXTRA	(4) HIGHEST NUMBER PREVIOUSLY PAID FOR		HIGHEST NUMBER PRESENT		UMBER PRESENT RATE			: (7) ADDITIONA FEES	
TOTAL CLAIMS	22	MINUS		22	=	0	х	\$18	\$	0	
INDEP. CLAIMS	4	MINUS		4	=	O	х	\$86	\$	Đ	
[] FIR	ST PRESENTATION OF A	MULTIPLE	DEPENDENT	CLAIM	*****		+	\$290	\$	0	
XTENSION FEE	1 ST MONTH \$110.00		МОМТН 0.00	3RD MON \$950.00	гн	1	1 MON 480.0		\$	0	
						0	THER	FEES	\$		
			TOTAL A	ODITIONAL FE	E FOR	THIS AI	MEND	MENT	\$	0	

Charge \$ 0 to Deposit Account 08-2025. At any time during the pendency of this application, please charge any fees required or credit any overpayment to Deposit Account 08-2025 pursuant to 37 CFR 1.25. Additionally please charge any fees to Deposit Account 08-2025 under 37 CFR 1.16, 1.17, 1.19, 1.20 and 1.21. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

(X) I hereby certify that this paper is being transmitted to the Patent and Trademark Office facsimile number (703) 872-9306 on 01/09/2004 Number of pages: 17

Typed Name: Carlin Taylor

Signature:

Hodges et al.

William J. Breen, Ill

Attorney/Agent for Applicant(s)

Reg. No. 45,313

Date: 01/09/2004

Rev 10/03 (finAmdFax)

Telephone No.: (509) 324-9256

PAGE 1/17 * RCVD AT 1/9/2004 12:09:42 PM [Eastern Standard Time] * SVR:USPTO-EFXRF-1/1 * DNIS:8729306 * CSID:509 323 8979 * DURATION (mm-ss):04-46

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Application Serial No.	10/052 212
Confirmation No	8400
Filing Date	January 18, 2002
Inventor	Hodges et al
Applicant	Hewlett-Packard Company
Group Art Unit	2823
Examiner	Lee, Hsien Ming
Attorney's Docket No.	10004054-1
Title: "Semiconductor Device with Deposited Oxide	

RESPONSE TO OFFICE ACTION DATED OCTOBER 31, 2003

To: Commissioner of Patents and Trademarks,

P.O. Box 1450

Alexandria, VA 22313-1450

From: William J. Breen, III

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Spokane, WA 99201 509.324.9256 x249

This communication is in response to the Office Action dated October 31, 2003, for which a three-month shortened statutory period for response is set for January 31, 2004. Please amend the above-identified application in accordance the directions set forth below.

Amendments to the Claims are reflected in the listing of claims which begin on page 2 of this paper.

Remarks begin on page 7 of this paper.